

Application No. 10/603,310
Amdt. dated December 13, 2006
Reply to Office Action of September 13, 2006

Docket No.: 20793/0204471-US0

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(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Rafael STORZ

Application No.: 10/603,310

Confirmation No.: 5265

Filed: June 25, 2003

Art Unit: 2878

For: METHOD FOR SETTING THE SYSTEM
PARAMETERS OF A SCANNING
MICROSCOPE

Examiner: Bui Pho, Pascal M.

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 13, 2006

Sir:

INTRODUCTORY COMMENTS

In response to the final office action dated September 13, 2006 received in the above-identified application, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of the claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.